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the Cu₂O – BiVO₄ Particle Interface – Evidence for Tandem
Excitation**

Journal:	<i>ChemComm</i>
Manuscript ID	CC-COM-05-2018-004123.R1
Article Type:	Communication

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COMMUNICATION

Wavelength Dependent Photochemical Charge Transfer at the Cu₂O – BiVO₄ Particle Interface – Evidence for Tandem Excitation

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Received 00th January 20xx,
Accepted 00th January 20xx

DOI: 10.1039/x0xx00000x

www.rsc.org/

The understanding of the photochemical charge transfer properties of powdered semiconductors is of relevance to artificial photosynthesis and the production of solar fuels. Here we use surface photovoltage spectroscopy to probe photoelectrochemical charge transfer between bismuth vanadate (BiVO₄) and cuprous oxide (Cu₂O) particles as a function of wavelength and film thickness. Optimized conditions produce a -2.10 V photovoltage under 2.5 eV (0.1 mW cm⁻²) illumination, which suggests the possibility of a water splitting system based on a BiVO₄ – Cu₂O direct contact particle tandem.

The photoelectrochemical water splitting reaction can provide hydrogen fuel from only solar energy and water. To generate the required water electrolysis potential of approximately 1.6 V, two or more mid gap semiconductors are typically used in series.^{1,2} The ideal limiting solar to hydrogen efficiency of a dual absorber configuration (28 %) ³⁻⁵ is about twice that of a single absorber system.²⁻⁹ Tandem devices for the water splitting reaction often rely on monolithic absorber stacks ¹⁰⁻¹⁹ that are difficult and expensive to fabricate because they require slow vacuum deposition methods, such as metal organic chemical vapour deposition (MOCVD). This problem is avoided in particle based tandem systems, where the Ohmic contact between the light absorbers is established through soluble redox couples, I₃⁻/I⁻, or Fe³⁺/Fe²⁺, or through direct physical contact. Examples for this type of tandem system include suspended TiO₂ particles,²⁰ tandems made of SrTiO₃:Ru-BiVO₄,^{21,22} the ZrO₂/TaON and WO₃ tandem system,^{23,24} and the RuO₂-TaON and Pt-TaON overall water splitting system.²⁵⁻²⁷ While particle contacts are easy to manufacture, photochemical charge transfer dynamics at these 'rough' interfaces and their dependence on surface morphology, electrolyte environment,²⁸ and particle size are not well understood. As particles get smaller, the effect of

internal electric fields (space charge layers) diminishes, and charge transfer is dominated by the relative concentrations of the charge carriers, the energetics of donor and acceptor configuration, and by surface and interfacial states of the particles.²⁹ Understanding these factors is important for raising the energy conversion efficiency of particle-based systems. Here we use surface photovoltage spectroscopy (SPS) to study photochemical charge transfer at the interfaces of Cu₂O and BiVO₄ nanoparticles. In SPS, the contact potential difference (CPD) of a sample film is measured under illumination with a semi-transparent Kelvin probe.³⁰⁻³³ A photovoltage (Δ CPD) can result from the movement of the charge carriers through the film or from their transfer across the interface between the particle film with another component of the circuit.^{34,35} This provides information about the majority carrier type, intermediate states, and the effective band gap of the semiconductor, with high sensitivity.^{29,34-36} We chose n-BiVO₄ for this study because it is a known photoanode ³⁷⁻⁴³ and photocatalyst material for water oxidation under 2.5 eV bandgap illumination.^{23,43-45} As second absorber, p-Cu₂O (2.1 eV) is used because it is a promising photocathode material for tandem PEC devices.^{46,47} As we show in the following, a tandem junction is formed at the BiVO₄-Cu₂O interface by simply layering these nanoparticles and by mildly annealing at 350 °C. This suggests the possibility of artificial photosynthetic system based on powders of these two materials. It may also explain the improved photocatalytic dye degradation performance of Cu₂O/BiVO₄ composites previously reported in the literature.⁴⁸⁻⁵⁰ Cu₂O nanoparticles for the study were synthesized from copper(II) acetylacetonate in acetone (Details in Supporting Information).⁵¹ The reaction affords Cu₂O nanoparticles in the Cuprite structure type with an average size of 59 ± 17 nm (**Figure 1E**, XRD in **Figure S1**) and cubic microcrystals, with 1 μm edge length (**Figure 1F**). Based on TEM images, the mass ratio of both particle sizes is 1:1. The BiVO₄ nanoparticles for the study were synthesized from Bi₂O₃ and V₂O₅ in acetic acid, using a revised method.⁴⁹ The material crystallizes in the Scheelite structure

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* Electronic Supplementary Information (ESI) available: Experimental Details, XRD, SEM and UV/vis data. DOI: 10.1039/x0xx00000x

type (Figure S1) and forms particles of 73 ± 35 nm average size (Figure 1B).

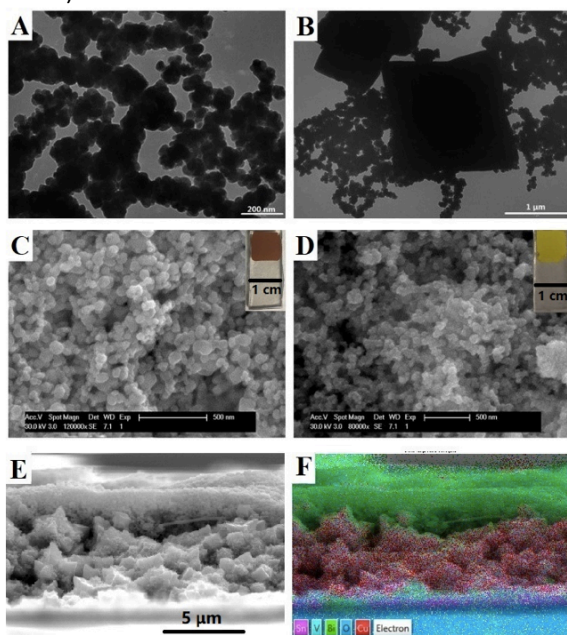


Figure 1. Transmission electron microscope images for A) BiVO_4 and B) for Cu_2O particles. Scanning electron microscope images for C) Cu_2O single layer, top view (photo in insert) and D) BiVO_4 single layer, top view (photo in insert). E) FTO- BiVO_4 - Cu_2O double layer, cross view. F) Energy-dispersive X-ray spectroscopy (EDS) element map overlaid onto SEM image.

Thin films of the particles were prepared by drop-casting suspensions on FTO substrates, followed by drying in air and annealing at 350°C under argon for 5h. These films have a red-brown (Cu_2O) or yellow (BiVO_4) appearance and contain the particles in loosely packed form (Figure 1CD and inserts). Surface photovoltage and optical spectra for separate BiVO_4 and Cu_2O particle films on FTO are presented in Figure 2. The spectrum for BiVO_4 contains a negative photovoltage feature that can be attributed to photoinduced electron transport to the FTO substrate, as expected for an n-type semiconductor.⁵² The 2.45 eV onset is slightly below the 2.55 eV optical absorption onset of the material (Figure 2), which is attributed to defect states near the band edges. In contrast, the photovoltage signal for the Cu_2O particle film on FTO has a positive sign. Here, the voltage results from injection of hole majority carriers into the FTO substrate. The onset energy of 2.0 eV corresponds well to the absorption spectrum of the material and to the optical band gap reported in the literature.⁵⁶ The photovoltage spectra can be understood on the basis of the energetics of the FTO/sample configurations, as shown in Figure 3A and B. Fundamentally, the photovoltage of a particle film is determined by the offset of the FTO workfunction (Fermi energy) and the band edges of the light absorber. These offsets are +0.3 V and -0.35 V for Cu_2O and BiVO_4 on FTO, respectively. The experimentally observed photovoltage values (+70 mV for Cu_2O and -165 mV for BiVO_4) are substantially lower, which is attributed mainly to the low light intensity of the light source (0.1 to 0.3 mW cm^{-2}). For example, in a previous study it was

found that the photovoltage was found to vary with the logarithm of the light intensity.^{34, 53} Another reason is that the sample film thickness is below the optical absorption depth of each material (see discussion below).

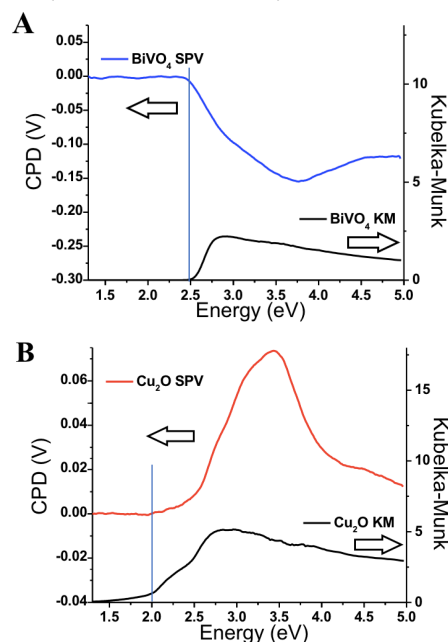


Figure 2. Surface photovoltage spectra and diffuse reflectance optical absorption spectra of A) 0.80 micrometer thick BiVO_4 film on fluorine doped tin oxide (FTO), and B) 0.72 micrometer thick Cu_2O film on FTO. KM stands for Kubelka-Munk.

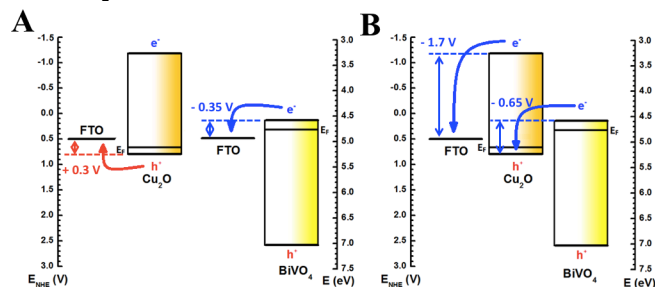


Figure 3. Energy scheme for A) FTO/ Cu_2O and FTO/ BiVO_4 single layer films and B) energy scheme for FTO/ Cu_2O / BiVO_4 bilayer film using band edges from the literature.^{44, 46}

Next, to evaluate photochemical charge transfer between Cu_2O and BiVO_4 , a stacked particle film was assembled by two sequential drop-casting steps each followed by annealing in argon at 350°C . Scanning electron micrographs of the stacked film are shown in Figure 1C/D together with EDS analysis results in Figures 1D and S2. Two distinct 3-5 micrometer thick layers of BiVO_4 nanoparticles at the top and loosely packed Cu_2O nano- and microparticles at the bottom can be observed. Elemental mapping confirms the composition of each layer with no particle intermixing occurring. Surface photovoltage spectra for FTO/ Cu_2O / BiVO_4 stacks with variable layer thicknesses are shown in Figure 4. Layer thicknesses were chosen in the 2.5 to 5 μm range to ensure optimal light absorption and charge transport. In all cases, a strongly negative photovoltage is observed above 2.25 eV. This voltage reaches a maximum

around 2.5 eV where both materials can absorb light (Figure 4A), and then decays at higher photon energies, due to the decrease in light penetration depth at higher photon energy. The sign of the voltage and its size indicates that both absorbers now act in tandem, as shown in the excitation scheme in Figure 3B. Holes from Cu₂O are no longer injected into the bottom FTO but into the top BiVO₄ layer where they recombine with majority carriers formed under BiVO₄ excitation. This reversal of the charge transfer direction in the Cu₂O particle layer is attributed to the Ohmic nature of the Cu₂O-BiVO₄ contact, which promotes majority carrier transfer across this interface.

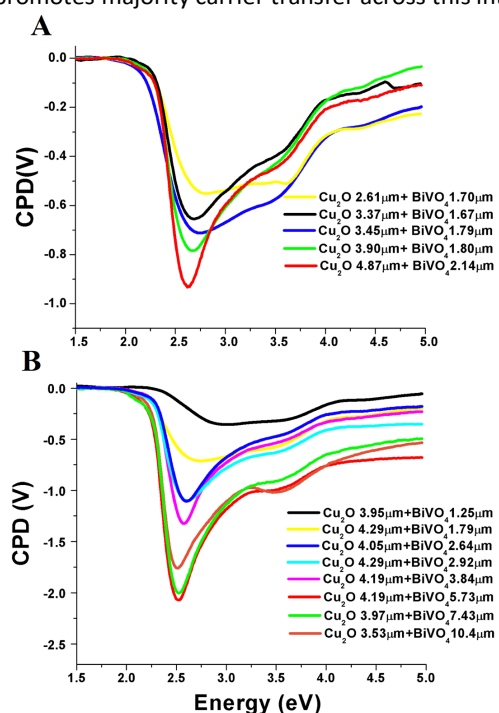


Figure 4. Surface photovoltage spectra for FTO-Cu₂O-BiVO₄ bilayer stacks. A) with variable Cu₂O layer thickness and nearly constant BiVO₄ layer thickness, B) with variable BiVO₄ layer thickness and nearly constant Cu₂O layer thickness.

As can be seen from Figure 4, the shape of the photovoltage spectra and the maximum photovoltage depend strongly on the thickness of the Cu₂O and BiVO₄ layers. Spectra in Figure 4A were acquired for variable Cu₂O layer thickness while holding the BiVO₄ layer constant at ~2 micrometer. As the Cu₂O particle layer gets thicker, the photovoltage maximum increases and reaches -0.93 V for a 4.8 μm thick film. This linear dependence (see also plot in Figure 5A) is expected if the photovoltage is limited by the light harvesting ability of the Cu₂O layer. The optical absorption coefficient for Cu₂O single crystals is 7.0x10⁵ cm⁻¹ at 2.5 eV,⁵⁴ which corresponds to an optical penetration depth of 1/α = 1.43 μm (or 3/α = 4.3 μm to absorb 95% of the incoming light). For loosely packed Cu₂O particles, 3/α will be greater, which confirms that light harvesting is a limiting issue in the particle layer. Incomplete light absorption at 2.5 eV is the likely reason why the photovoltage maximum for the thinnest Cu₂O film (2.61 μm) occurs at 2.8 eV, where light absorption is improved. Some of this effect is seen for the 3.45 μm thick film, which is attributed to thickness variations across the 1.0 cm² sample. Figure 4B summarizes spectra acquired for FTO/Cu₂O/BiVO₄ stacks with the Cu₂O layer held constant at ~4

μm and Figure 5 plots the maximum photovoltage versus BiVO₄ layer thickness. It can be seen that the photovoltage increases until the BiVO₄ layer thickness reaches 5.73 μm and then decreases for thicker films. This behaviour was previously observed for a silicon-BiVO₄ tandem.⁵² It was attributed to limiting light absorption in the thin films and limiting charge transport in the thicker films. A balance between these two parameters occurs at 5.73 μm. This value is below light penetration depth (3/α = 9.1 μm for 95% light absorption) of a BiVO₄ particle film (Figure S3).

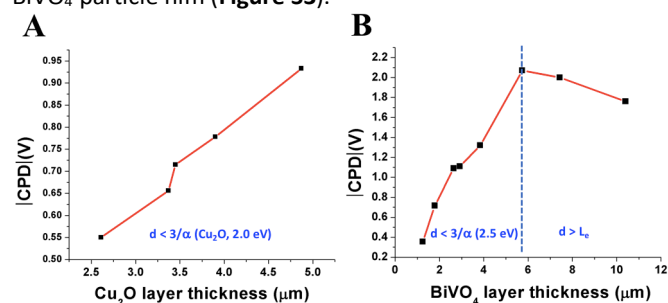


Figure 5. Photovoltage versus A) Cu₂O thickness and versus B) BiVO₄ thickness *d*. *L_e*: electron diffusion length, α: optical absorption coefficient at 2.5 eV.

That indicates that electron diffusion in BiVO₄ is limiting the photovoltage. Indeed, for non-doped BiVO₄, the electron diffusion length, *L_e*, is only 10–70 nm.^{55,56} The SPS data in Figure 4B also shows a shift of the photovoltage maximum position to lower photon energy as the BiVO₄ layer thickness increases. This is because the light passing through the BiVO₄ film becomes increasingly red shifted. An optimized FTO/Cu₂O/BiVO₄ stack at 4.19 μm Cu₂O and 5.73 μm BiVO₄ generates the largest photovoltage of -2.1 V at 2.5 eV. This photovoltage corresponds to 90% of the theoretically possible voltage (-2.35 V), as defined by sum of the *E_{CB}*-*E_F* offsets at the Cu₂O-FTO interface (-1.7 V) and the *E_{VB}*-*E_{CB}* offset at the Cu₂O-BiVO₄ interface (-0.65 V) in Figure 3B. Based on this analysis, photochemical charge separation in the FTO/Cu₂O/BiVO₄ stack is 90% efficient under the vacuum conditions of the SPS experiment.

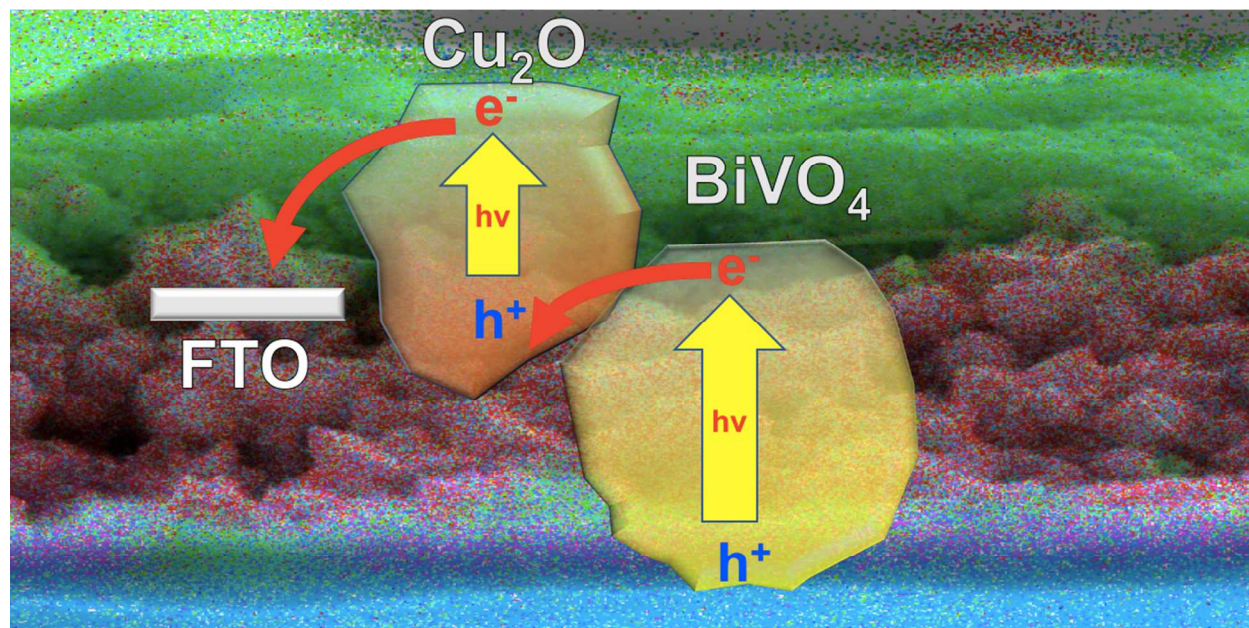
In conclusion, we have employed surface photovoltage spectroscopy to observe photochemical charge transfer in Cu₂O and BiVO₄ particle films as a function of wavelength for the first time. Isolated Cu₂O particle layers on FTO show p-type behavior and BiVO₄ particles show n-type behavior. In a FTO/Cu₂O/BiVO₄ particle stack, both particles act in tandem, producing up to -2.1 V photovoltage under 2.5 eV excitation, which corresponds to 90% of the ideal limit. The photovoltage spectra also reveal the effects of shading at high excitation energy and the effects of low absorber strength at low excitation energy. These results are relevant to the understanding of photochemical charge transfer at irregular particle surfaces and to the construction of devices for artificial photosynthesis and water splitting.

This work was supported through funding from the U.S. Department of Energy, Office of Science, Office of Basic Energy Sciences under Award Number DE-SC0015329.

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Surface photovoltage spectroscopy resolves wavelength-dependent photochemical charge transfer between irregularly shaped BiVO_4 and Cu_2O particles for the first time.